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Paper No. 22

Date : January 5, 2004  
TO : Director, Office of Publication and Dissemination  
FROM : Office of the Deputy Commissioner  
for Patent Examination Policy  
SUBJECT : Withdrawal from Issue of  
Applicant(s) : Vishnu K. Agarwal et al  
Application No. : 09/590,795  
Filed : June 8, 2000

The above-identified application has been assigned Patent No. 6,673,666 and an issue date of January 6, 2004.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of January 6, 2004:

"All reference to Patent No. 6,673,666 to Vishnu K. Agarwal et al of Idaho for METHODS FOR FORMING AND INTEGRATED CIRCUIT STRUCTURES CONTAINING RUTHENIUM AND TUNGSTEN CONTAINING LAYERS appearing in the Official Gazette of January 6, 2004 should be deleted since no patent was granted."

*Karen Creasy*

Karen Creasy  
Petitions Examiner  
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